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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 2800

PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Box AF, Commissioner of Patents, Washington, DC 20231.

Date

Ayesha S. Wilks

January 27, 2003 *[Signature]* *ASW* *2/12/03*
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE *January 27, 2003*

Applicant : Vishnu K. Agarwal Attorney Docket No. : 501082.10 (98-0616.09)
Serial No. : 09/652,714 Group Art Unit : 2815
Filed : August 31, 2000 Examiner : Jose R. Diaz
Title : DEVICE AND METHOD FOR PROTECTING AGAINST OXIDATION OF A CONDUCTIVE LAYER IN SAID DEVICE

Box AF
Commissioner of Patents
Washington, DC 20231

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

Please amend the above-captioned patent application as follows:

In the Claims:

Please amend claims 37, 82, 86, and 95 as follows:

E 1
Sub F
comprising:

37. (Twice Amended) A method of forming a semiconductor device,
depositing a first conductive layer having a surface and having an ability
to associate with oxygen;

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